U.S. Patent Application Serial No. 10/050,169

IN THE CLAIMS:

Please amend claims 5 and 11 as follows:

- 5. (Amended) The semiconductor memory device according to claim 4, wherein said silicon nitride layer is patterned to have a same planar shape as the opposing electrode.
- 11. (Amended) The semiconductor memory device according to claim 10, wherein said lower part of the insulator laminate includes a silicon nitride layer at an uppermost level, which is patterned to have a same planar shape as the opposing electrode.